



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Masatoshi YASUTAKE et al. :
Serial No. 10/775,724 : Group Art Unit - 2823
Filed: February 10, 2004 : Examiner- Quovaunda Jefferson
For: PREPARATION OF SAMPLE :
CHIP, METHOD OF OBSERVING :
WALL SURFACE THEREOF AND :
SYSTEM THEREFOR : Docket No. S005-5210

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P.O. Box 1450
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**AMENDMENT AFTER FINAL
UNDER RULE 116**

S I R:

In response to the Office Action dated June 29,
2006, applicants request reconsideration of their application
as follows:

ADDITIONAL FEES:

No additional fees are believed required in
connection with this amendment; however, should it be
determined that a fee is due, authorization is hereby given to
charge any such fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 17